

ABSTRACT OF THE DISCLOSURE

As a method of fabricating aspherical microstructures, a
5 protruding microstructure is formed on a substrate, an aspherical-profile
forming layer is formed on the substrate and the protruding microstructure,
and the aspherical-profile forming layer is hardened. An aspherical
profile is formed on the protruding microstructure due to a surface tension
of the aspherical-profile forming layer in the step of forming the
10 aspherical-profile forming layer, and the aspherical profile is maintained
through the step of hardening the aspherical-profile forming layer.